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CONFIRMATION NO. 2419

| SERIAL NUMB 10/540,720 | | | | GROUP ART UNIT 2812 | | | ATTORNEY DOCKET NO. 450101-04870.1 | | |
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| APPLICANTS Koichiro Kishima, Kanagawa, JAPAN; Prakash Koonath, Los Angeles, CA; *** CONTINUING DATA ******************* This application is a 371 of PCT/JP04/16188 10/25/2004 which claims benefit of 60/514,379 10/24/2003 *** FOREIGN APPLICATIONS ************************************ | | | | | | | | | |
| IX5 LISC 119 (2-d) conditions | | | | | DRA | SHEETS TOTAL DRAWING CLAI 10 20 | | MS | INDEPENDENT CLAIMS 4 |
| ADDRESS William Frommer Frommer Lawrence & Haug 745 Fifth Avenue New York ,NY 10151 | | | | | | | | | |
| TITLE Method for manufacturing semiconductor substrate and semiconductor substrate | | | | | | | | | |
| RECEIVED | FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following: | | | | All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other Credit | | | | |